Search Notes			

Application/Control No.	Applicant(s)/Patent unde Reexamination	r
10/706,755	KIM ET AL.	
Examiner	Art Unit	
Stephen W. Smoot	2813	

SEARCHED			
Class	Subclass	Date	Examiner
257	75	2/25/2005	sws
257	347	2/25/2005	sws
257	503	2/25/2005	sws
257	506	2/25/2005	sws
257	524	2/25/2005	sws

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
	-			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
Key Words: Isolation - Shallow Trench, STI, Field Oxide, FOX;	2/25/2005	S.W.S sws	
Buried Insulator - Oxide, BOX, Silicon- on-Insulator, SOI; Epitaxial Layer - Silicon.	2/25/2005	I.W.S sws	
		89,5	
Search Tools - EAST (attached): USPAT; US PG PUBS; Derwent; EPO; JPO; IBM TDB	2/25/2005	sws	